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A dual-wavelength tunable laser with superimposed fiber Bragg gratings

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Abstract

We report a dual-wavelength tunable fiber laser. The cavity is formed by two superimposed fiber Bragg gratings (FBGs) and a temperature tunable high-birefringence fiber optical loop mirror (FOLM). FBGs with wavelengths of 1548.5 and 1538.5 nm were printed in the same section of a fiber using two different masks. The superimposed FBGs were placed on a mechanical mount that allows stretch or compression of the FBGs. As a result of the FBG strain both lines are shifted simultaneously. Dual-wavelength generation requires a fine adjustment of the cavity loss for both wavelengths.

1. Introduction

Different methods have been proposed and demonstrated for generating dual or multi-wavelengths in fiber lasers. There are potential applications in a variety of research areas, such as fiber-based sensors, wavelength division multiplexing (WDM), optical communication systems and instrument testing among others [1–3]. Erbium-doped fibers (EDF) are attractive optical media for dual-wavelength generation providing compatibility with existing technology, wide gain bandwidth and simplicity. However, EDF is a homogeneous gain medium at room temperature, which leads to strong mode competition and difficulties for simultaneous generation of two or more laser lines. The most common way to ensure the stable generation of several lines consists of introducing different cavity losses for generating lines. Several methods to adjust the losses within the laser cavity to obtain simultaneous and stable laser emission have been proposed [4–6].

Fiber Bragg gratings (FBGs) are optical devices widely used in fiber laser design for wavelength selection due to their narrow band reflection. For dual-wavelength lasers an array of cascaded FBGs is usually used [2, 7]. Lasers using only one FBG with multiple reflection wavelengths, including FBGs written in few-mode or multimode fiber and FBGs written in high-birefringence (Hi-Bi) fiber, have also been reported [8, 9].

In this paper, we report a simple tunable dual-wavelength linear cavity fiber laser using superimposed FBGs written in the same point of an optical fiber segment allowing reflection at two different Bragg wavelengths. For loss adjustment we use a fiber optical loop mirror (FOLM) with a Hi-Bi fiber in the loop. Superimposed FBGs were placed on a mechanical mount that allows stretch or compression of the FBGs. The proposed fiber laser generates two simultaneous laser lines with equal or unequal output powers and tuning ability for both wavelengths, preserving the same separation between

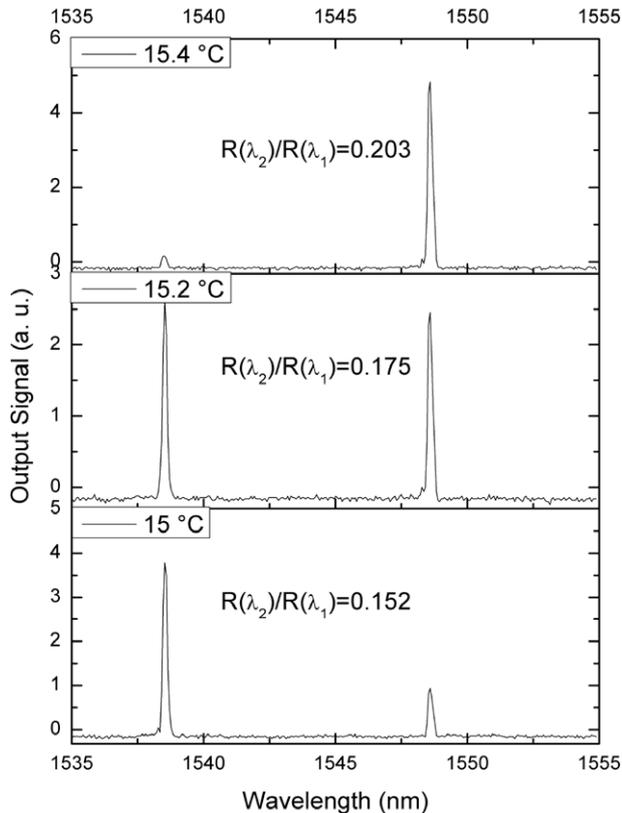


Figure 3. The laser spectra at a Hi-Bi fiber temperature equal to 15.2 °C (equal power of laser lines), and temperatures equal to 15.4 and 15.2 °C. The ratios between the FOLM reflections for λ_2 and λ_1 are shown in the figures for each temperature.

our measurements we set the maximum of the transmission spectra to 0.9. The calculated constant A for this adjustment is equal to 9/11.

Figure 3 presents the laser output spectrum at different temperatures of the Hi-Bi fiber in the FOLM without strain applied to the FBGs. Laser wavelengths are displayed at 1538.5 nm and 1548.5 nm. At a temperature of 15.2 °C two peaks with equal amplitudes were observed. At a temperature of 15 °C two peaks are still observed; however, the amplitude of the peak with the shorter wavelength is higher than that of the peak with the longer wavelength. The increase in temperature to 15.4 °C results in a higher amplitude of the peak with the longer wavelength. As can be seen, the laser operation range is about 0.4 °C. For each temperature we calculated the ratio between reflection of the FOLM for long and short wavelengths, $R(\lambda_2)/R(\lambda_1)$. As can be seen dual-wavelength operation is observed for the range of $R(\lambda_2)/R(\lambda_1)$ between approximately 0.15 and 0.2.

Figure 4 shows the laser wavelengths for different strains applied to FBGs using the micrometric screw. The maximum stretch was 80 μm with intervals of 10 μm . The relation between micrometric displacement and wavelength shift of the FBG is around 0.79 nm/10 μm . The maximum wavelength shift was 5.58 nm. As can be seen, the measured data have an approximately linear behavior. The separation between laser lines is 10 nm independent of strain. The temperature

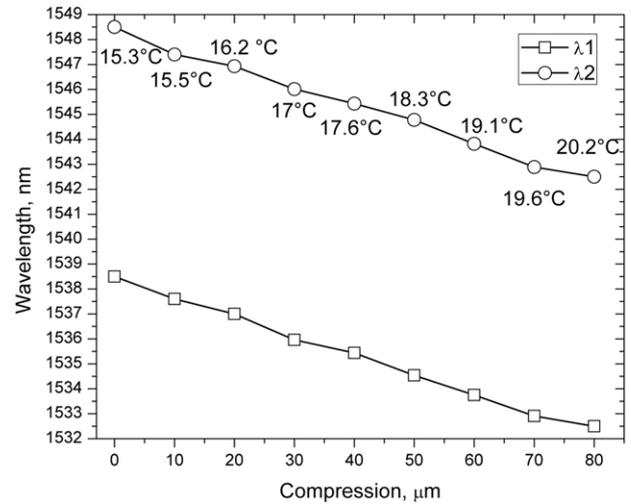


Figure 4. Dual laser wavelength shift with respect to axial compression of the FBG at different temperatures.

of the Hi-Bi fiber in the loop of the FOLM required for dual-wavelength generation is shown in figure 4 for each compression.

The use of the FOLM for loss adjustment allows the investigation of tolerance of dual-wavelength generation to the ratio between the cavity losses at λ_1 and λ_2 . Figure 5(b) shows reflections of the FOLM for λ_1 and λ_2 required for dual-wavelength generation calculated using equation (1). Figure 5(a) shows the ratio $R(\lambda_2)/R(\lambda_1)$. At low FBG compressions both laser lines are situated on the plateau of the EDF amplification and we can see that the reflection for short wavelength is higher than that for long wavelength. When $R(\lambda_1)$ is approaching the amplification peak of the EDF spectrum (around 1533 nm), reflection $R(\lambda_2)$ increases and reflection $R(\lambda_1)$ decreases with compression.

4. Conclusions

We experimentally investigated the emission of a tunable dual-wavelength laser with a linear cavity formed by superimposed FBGs and a FOLM with a Hi-Bi fiber in the loop. Tunable superimposed FBGs were placed on a mechanical mount that allows stretching or compression of the FBGs. The temperature control of the FOLM Hi-Bi fiber loop allows fine adjustment of the ratio between the cavity loss at λ_1 and λ_2 . Using this adjustment we were able to change the mode of operation of the laser from single wavelength to stable dual-wavelength generation with equal powers for λ_1 and λ_2 or to stable dual-wavelength generation with unequal powers at λ_1 and λ_2 . We have measured the change of the ratio $R(\lambda_2)/R(\lambda_1)$ between the FOLM reflection for λ_1 and λ_2 . When both lines are situated on the plateau of the EDF amplification the reflection of longer wavelengths was always higher than the reflection for shorter wavelengths.

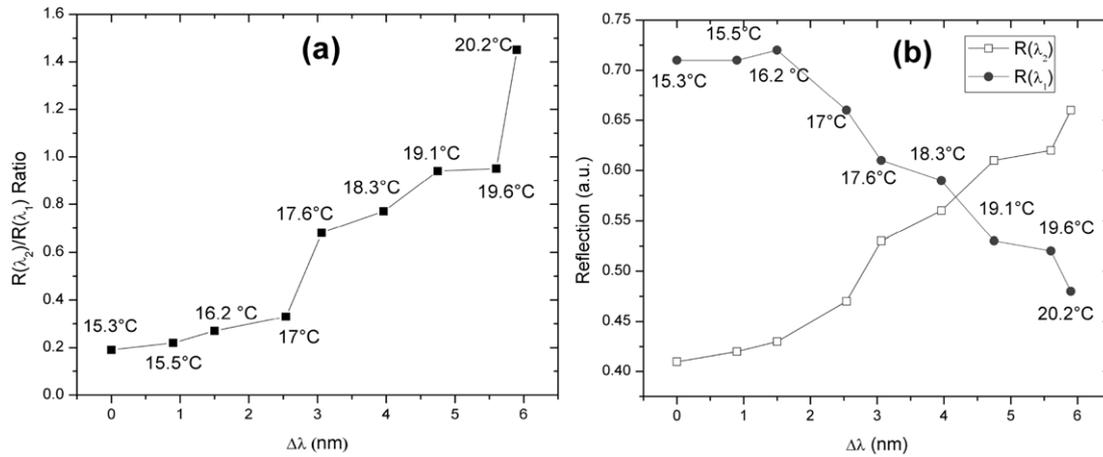


Figure 5. Calculated reflection at different compressions: (a) reflection ratio; (b) reflections $R(\lambda_2)$ and $R(\lambda_1)$.

Acknowledgments

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References

- [1] Luo A P, Luo Z C and Xu W C 2009 *Laser Phys. Lett.* **6** 598
- [2] Ahmad H, Zulkifli M Z, Thambiratnam K, Latif S F and Harun S W 2009 *Laser Phys. Lett.* **6** 380
- [3] Sonee-Shargh R, Al-Mansoori M H, Anas S B A, Sahbudin R K Z and Mahdi M A 2011 *Laser Phys. Lett.* **8** 139
- [4] Sun H B, Liu X M, Gong Y K, Li X H and Wang L R 2010 *Laser Phys.* **20** 522
- [5] Yeh C H, Shih F Y, Wang C H, Chow C W and Chi S 2008 *Laser Phys. Lett.* **5** 821
- [6] Latif A A, Zulkifli M Z, Awang N A, Harun S W and Ahmad H 2010 *Laser Phys.* **20** 2006
- [7] Durán-Sánchez M, Flores-Rosas A, Álvarez-Tamayo R I, Kuzin E A, Pottiez O, Bello-Jimenez M and Ibarra-Escamilla B 2010 *Laser Phys.* **20** 1270
- [8] Álvarez-Tamayo R I, Duran-Sánchez M, Pottiez O, Kuzin E A and Ibarra-Escamilla B 2011 *Laser Phys.* **21** 1932
- [9] Yan J H, Fu H Y and He S 2007 *Microw. Opt. Technol. Lett.* **49** 1509
- [10] Álvarez-Tamayo R I, Duran-Sánchez M, Pottiez O, Kuzin E A, Ibarra-Escamilla B and Flores-Rosas A 2011 *Appl. Opt.* **50** 253